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Patent Application ATM-515 (7486)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re United States Patent Application of: Docket No.: ATMI-515 (7486) Applicant: XU, Chongying, et al. Examinèr: Virginia MANOHARAN 10/015,326 Application No.: Art Group: 1764 Date Filed: December 13, 2001 Confirm. No.: 2946 Customer No.: Title: METHOD FOR REMOVAL OF IMPURITIES IN CYCLIC SILOXANES USEFUL AS PRECURSORS FOR LOW 25559 DIELECTRIC CONSTANT THIN FILMS

FACSIMILE TRANSMISSION CERTIFICATE ATTN: Examiner Virginia MANOHARAN

Fax No.: (571) 273-8300

I hereby certify that this document is being filed in the United States Patent and Trademark Office, via facsimile transmission to Mail Stop AF, Commissioner for Patents, PO Box 1450, Alexandria, VA 22313-1450, on July 25, 2005, to United States Patent and Trademark Office facsimile transmission number (571) 273-8300

Number of Pages (including cover)

Marianne Fuierer

July 25, 2005

RESPONSE TO MAY 25, 2005 OFFICE ACTION IN UNITED STATES PATENT APPLICATION NO. 10/015,326

Mail Stop AF Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

In response to the May 25, 2005 Office Action, please amend the application as follows: